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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *None S.W.L.*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *S.W.L.*  
JAPAN 11-336850 11/26/1999

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 27	TOTAL CLAIMS 43	INDEPENDENT CLAIMS 14
35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>S.W.L.</i> Examiner's Signature <i>Allowance</i> Initials				

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## TITLE

METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE THAT INCLUDES FORMING A MATERIAL WITH A HIGH TENSILE STRESS IN CONTACT WITH A SEMICONDUCTOR FILM TO GETTER IMPURITIES FROM THE SEMICONDUCTOR FILM

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